



2818  
JFW  
PATENT  
8040-1041

IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of:

Masamoto TAGO et al.

Confirmation No. 9072

Serial No. 09/613,331

GROUP 2818

Filed July 7, 2000

Examiner Quoc Dinh Hoang

SYSTEM SEMICONDUCTOR DEVICE AND METHOD  
OF MANUFACTURING THE SAME

AMENDMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

October 25, 2004

Sir:

Responsive to the Official Action of July 23, 2004,  
please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing  
of claims that begins on page 2 of this paper.

**Remarks** begin on page 7 of this paper.